

# Hong-Ping

## List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/9180470/publications.pdf>

Version: 2024-02-01

6  
papers

112  
citations

1936888

4  
h-index

1872312

6  
g-index

6  
all docs

6  
docs citations

6  
times ranked

207  
citing authors

#	ARTICLE	IF	CITATIONS
1	Annealing effect on SiN <sub>x</sub> /SiO <sub>2</sub> superlattice with ultrathin sublayer fabricated using plasma-enhanced atomic layer deposition. <i>Ceramics International</i> , 2022, 48, 22123-22130.	2.3	3
2	Formation of quasi-two-dimensional electron gas at the interface of ZnO/Ga <sub>2</sub> O <sub>3</sub> heterostructure. <i>AIP Advances</i> , 2021, 11, .	0.6	1
3	Systematic Study of the SiO <sub>x</sub> Film with Different Stoichiometry by Plasma-Enhanced Atomic Layer Deposition and Its Application in SiO <sub>x</sub> /SiO <sub>2</sub> Super-Lattice. <i>Nanomaterials</i> , 2019, 9, 55.	1.9	52
4	Precise control of the microstructural, optical, and electrical properties of ultrathin Ga <sub>2</sub> O <sub>3</sub> film through nanomixing with few atom-thick SiO <sub>2</sub> interlayer <i>via</i> plasma enhanced atomic layer deposition. <i>Journal of Materials Chemistry C</i> , 2018, 6, 12518-12528.	2.7	26
5	Enhanced piezoelectric performance of the ZnO/AlN stacked nanofilm nanogenerator grown by atomic layer deposition. <i>APL Materials</i> , 2018, 6, 121109.	2.2	10
6	Measurements of Microstructural, Chemical, Optical, and Electrical Properties of Silicon-Oxygen-Nitrogen Films Prepared by Plasma-Enhanced Atomic Layer Deposition. <i>Nanomaterials</i> , 2018, 8, 1008.	1.9	20